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CONFIRMATION NO. 8193

Bib Data Sheet

SERIAL NUMBER	FILING DATE	CLASS	GROUP ART UNIT	ATTORNEY DOCKET NO.
10/682,124	10/10/2003 RULE	257	2823	57454-976

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** CONTINUING DATA **********

This application is a DIV of 10/336,758 01/06/2003 PAT 6,653,656
which is a DIV of 09/677,848 10/03/2000 PAT 6,509,583
which is a DIV of 09/231,548 01/15/1999 PAT 6,144,072
which is a DIV of 08/794,504 02/04/1997 PAT 5,905,286
which is a CON of 08/461,777 06/05/1995 ABN

** FOREIGN APPLICATIONS **********

JAPAN 6-269695(P) 11/02/1994
JAPAN 6-334025(P) 12/15/1994

IF REQUIRED, FOREIGN FILING LICENSE GRANTED
** 01/15/2004

Foreign Priority claimed	STATE OR	SHEETS	TOTAL	INDEPENDENT
35 USC 119 (a-d) conditions met	COUNTRY	DRAWING	CLAIMS	CLAIMS
Verified and Acknowledged	JAPAN	108	36	22

yes ☐ no
☐ yes ☐ no ☐ Met after Allowance
Examiner's Signature Initials

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TITLE
Semiconductor device formed on insulating layer and method of manufacturing the same